

CLAIM LISTING:

This listing of claims will replace all prior versions and listings of claims in the application:

1. (Currently amended) A The method for treating hair of claim 21, wherein the device comprising:
a housing;
one or more ion generators for generating generates ions of positive polarity and ions of negative polarity; wherein said one or more ion emitters is a plurality of ion emitters for emitting ions of positive polarity and ions of negative polarity; wherein said plurality of ion emitters are situated adjacent, but outside said housing.
2. (Currently amended) The ~~device~~method for treating hair of claim 1, wherein said ions form ~~an~~said ion concentration outside said housing and at a distance from a user's hair.
3. (Currently amended) The ~~device~~method for treating hair of claim 2, wherein said hair is encompassed by said ion concentration.
4. (Canceled)
5. (Currently amended) The ~~device~~method for treating hair of claim ~~41~~1, wherein said housing has at least one aperture disposed therein forming an air outlet for directing said airflow.
6. (Canceled)
7. (Currently amended) The ~~device~~method for treating hair of claim ~~65~~5, ~~further comprising at~~wherein said least one attachment for cooperating with said air outlet to ~~manipulates~~manipulates said airflow exiting said air outlet.

8-11. (Canceled)

12. (Currently amended) The ~~device~~method for treating hair of claim 1, wherein said casing is selectively removable from said housing.

13- 20 (Canceled)

21. (Previously presented) A method for treating hair comprising the steps of:
providing a device having a housing with at least one air outlet disposed therein, a blower for generating an airflow stream, one or more ion generators, and one or more ion emitters disposed outside, but adjacent to said housing and spaced a distance from said airflow exiting said air outlet;

applying said blower generated airflow toward hair for drying and/or styling;
generating an ion concentration having a certain area and spaced a certain distance from said airflow to minimize any dilution resulting from direct exposure to said airflow; and

providing at least one attachment for cooperating with said air outlet of said housing for controlling the mixing of said ion concentration with said airflow stream and hair.

22. (Canceled).

23. (Previously presented) The method for treating hair of claim 21, wherein said at least one attachment is configured to variably control aspiration of said positive and negative ions into said airflow.

24. (Original) The method for treating hair of claim 23, wherein said at least one blower alters said airflow velocity, thereby controlling said aspiration of said positive and negative ions into said airflow.

25. (Original) The method for treating hair of claim 21, wherein said at least one ion generator is configured to provide a variety of voltage outputs, as well as to generate combinations of positive and negative ions.

26. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters is/are positioned in a casing formed on said housing.

27. (Original) The method for treating hair of claim 21, wherein said plurality of ion emitters are formed from a conductive metal.

28. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters is/are formed from a conductive polymer.

29. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters is/are formed from a conductive silicon.

30. (Previously presented) The method for treating hair of claim 21, wherein said one or more ion emitters form an array.

31. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters create an ion concentration having a negative polarity.

32. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters create an ion concentration having a positive polarity.

33. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters create an ion concentration having both a positive and negative polarity.

34. (Original) The method for treating hair of claim 21, wherein said one or more ion emitters is/are arranged to generate a predictable area of concentrated ions and to minimize any dilution resulting from direct exposure to said airflow.